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Page 1 of 1 SERIAL NO. ATTY. DOCKET NO. OF COMMERCE Form PTO-1449 09/925,679 ADEMARK OFFICE 025311-0107 (MODIFIED) **APPLICANT** Minoru Toriumi, et al. INFORMATION DISCLOSURE CITATION **GROUP ART UNIT** FILING DATE August 10; 2001 1752 (Use several sheets if necessary) U.S. PATENT DOCUMENTS FILING DATE SUB-**DOCUMENT EXAMINER CLASS** IF NAME DATE **CLASS** REF APPROPRIATE NUMBER INITIAL 270.1 430 Varanasi et al. 09/26/00 6,124,074 **A1** 430 326 Nozaki et al. 10/19/99 5.968,713 A2 NOV 1 6 2001 FOREIGN PATENT DOCUMENTS TRANSLATION SUB-**DOCUMENT CLASS** COUNTRY DATE . CLASS NO YES REF NUMBER EP 1 126 320 A2 08/22/01 **A3** 01/10/01 EP 1 067 112 A2 **A4 Abstract** JP 10/07/97 9-265177 **A5** Abstract JP 05/25/93 5-127370 A6 05/05/93 EP 0 540 032 A1 **A7** OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.) KAIMOTO, Y., " Alicyclic Polymer for ArF and KrF Excimer Resist Based on Chemical Amplification," SPIE, Vol. 1672 Advances in Resist Technology and Processing IX, pp. 66-73, 1992. **A8** DATE CONSIDERED

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communication to applicant.